



## IN THE U.S. PATENT AND TRADEMARK OFFICE August 5, 2008

Applicants: Atsushi YABE et al

For: ELECTROLESS COPPER PLATING SOLUTION AND

ELECTROLESS COPPER PLATING METHOD

Serial No.: 10/576 230 Group: 1792

Confirmation No.: 7180

Filed: April 14, 2006 Examiner: Bareford

International Application No.: PCT/JP2004/014049

International Filing Date: September 17, 2004

Atty. Docket No.: 4700.P0328US

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **RESPONSE**

Sir:

In response to the Office Action dated May 8, 2008, please amend the above-identified application as follows: (Please see following pages.)

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 5, 2008.

Terryence F. Chapman